## Arcing behavior during plasma electrolytic oxidation of light metals

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Anodic oxidefilms can be formed on light metals, such as Mg, Al and Ti alloys, by plasmaelectrolytic oxidation (PEO) process in liquid solutions containing variousanions, such as OH, PO<sub>4</sub><sup>3-</sup>, SiO<sub>3</sub><sup>2-</sup>, CO<sub>3</sub><sup>2-</sup>, F<sup>-</sup> and AlO<sub>2</sub><sup>-</sup>. PEO process includes alwaysthe generation of light and heat by arcings. Small and large arcing sound canbe accompanied with the generation of light. Some arcs are generated uniformlyover the whole surface, which is called as uniform arcing, and some arcs occur onlyat a specific site, which is called as group arcing. Some arcs are randomly generated, not depending on the position of previous arcs, called as random discharge, andsome others are generated at the neighboring site of the previous arcs which result in the movement of arcs as a form of line and it is called as linear discharges or moving arcs. In general, uniform and random arcings result in thinand smoother PEO films while group arcings form thick and porous PEO films. PEO films can be grown vertically or laterally, depending on the solution composition, form of applied current and PEO treatment time. In this presentation, PEO film formation behavior on Al and Mg alloys will be discussed on the basis of arcing behavior under the application of DC and pulse current inaqueous solutions.